Igor A Konyakhin

List of Publications by Year in descending order

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1163117 1281871 57 221 8 11 citations g-index h-index papers 61 61 61 56 docs citations times ranked citing authors all docs

#	Article	IF	CITATIONS
1	Three-coordinate digital autocollimator. Journal of Optical Technology (A Translation of Opticheskii) Tj ETQq1 1 0.	.784314 r	gBT/Overloc
2	Iterative algorithm for determining the coordinates of the images of point radiators. Journal of Optical Technology (A Translation of Opticheskii Zhurnal), 2009, 76, 36.	0.4	13
3	Optic-electronic systems for measuring the angle deformations and line shifts of the reflecting elements at the rotateable radio-telescope. Proceedings of SPIE, $2011, $, .	0.8	12
4	Optic-electronic autocollimation sensor for measurement of the three-axis angular deformation of industry objects. Proceedings of SPIE, 2012, , .	0.8	9
5	Research of autocollimating angular deformation measurement system for large-size objects control. Proceedings of SPIE, 2013, , .	0.8	9
6	Study of a multi-array optoelectronic system for monitoring the elements of the Suffa RT-70 radio telescope. Journal of Optical Technology (A Translation of Opticheskii Zhurnal), 2013, 80, 769.	0.4	9
7	Optic-electronic systems for measurement the three-dimension angular deformation of axles at the millimeter wave range radiotelescope. Proceedings of SPIE, 2013 , , .	0.8	9
8	Vision-based system for long-term remote monitoring of large civil engineering structures: design, testing, evaluation. Measurement Science and Technology, 2018, 29, 115003.	2.6	9
9	Three-axis optic-electronic autocollimation system for the inspection of large-scale objects. , 2013, , .		7
10	Survey of illuminance distribution of vignetted image at autocollimation systems by computer simulation. Proceedings of SPIE, 2013, , .	0.8	7
11	High precision multimatrix optic-electronic modules for distributed measuring systems. , 2010, , .		6
12	High Precision Angular and Linear Measurements Using Universal Opto-Electronic Measuring Modules in Distributed Measuring Systems. Key Engineering Materials, 2010, 437, 160-164.	0.4	6
13	Optic-electronic system for measuring the three-dimensional angular deformation of pipe sections at large constructions. , 2015, , .		6
14	Development of optoelectronic autocollimation devices for monitoring angular displacements. Journal of Optical Technology (A Translation of Opticheskii Zhurnal), 2000, 67, 344.	0.4	5
15	Study of the structural features of invariant optoelectronic systems with a unified matrix analysis field. Journal of Optical Technology (A Translation of Opticheskii Zhurnal), 2007, 74, 810.	0.4	5
16	The experimental research of the systems for measuring the angle rotations and line shifts of the large aperture radio-telescope components. , 2010 , , .		5
17	Study of the influence of the tetrahedral reflectors properties on autocollimating systems characteristics. , 2010, , .		5
18	Electrooptic converter to control linear displacements of the large structures of the buildings and facilities., 2015,,.		5

#	Article	IF	CITATIONS
19	Universal opto-electronic measuring modules in distributed measuring systems. , 2008, , .		4
20	Inner-Base Optoelectronic System for the Control of Linear Displacements. Key Engineering Materials, 2010, 437, 237-241.	0.4	4
21	Determination of parameters and research autoreflection scheme to measurement errors relative position of the optical elements of the Space Telescope. Proceedings of SPIE, 2014, , .	0.8	4
22	Monitoring deformations of industrial objects using optical-electronic autoreflection system. , 2015, , .		4
23	Configurations of the reflector for optical-electronic autocollimator., 2016,,.		4
24	Optical-electronic system for real-time structural health monitoring of roofs. , 2016, , .		4
25	Precision System for Motion Path Parameters Measurement of Wheel and Rail Transport. Journal of Physics: Conference Series, 2006, 48, 998-1002.	0.4	3
26	Research on the Methods to Compensate the Systematic Error at Optical Autoreflection Angular Measurements. Journal of Physics: Conference Series, 2006, 48, 932-936.	0.4	3
27	Multipurpose optic-electronic autocollimators for measuring deformations of the axle with a millimeter wave range radiotelescope. , $2015, \ldots$		3
28	Method of increasing the working distance of optical-electronic autocollimator. , 2015, , .		3
29	Optic-Electronic Systems for Control the Angle and Line Positions of the Elements Unblocked Aperture Radio-Telescope. Key Engineering Materials, 0, 437, 203-207.	0.4	2
30	Approximation of large radio telescope surface with measurement data of optic-electronic stereoscopic system. Proceedings of SPIE, 2013, , .	0.8	2
31	Optic-electronic sensor for measuring the deformations of the axle at the radio-telescope. , 2014, , .		2
32	Design of autocollimation systems by modelling an illuminance distribution of a vignetted image. Proceedings of SPIE, 2014, , .	0.8	2
33	Optic-electronic systems for measurement a position of radio-telescope components. Proceedings of SPIE, 2015, , .	0.8	2
34	Optical-electronic system for real-time position control of roof's supporting structure. , 2015, , .		2
35	Autocollimating systems for roll angle measurement of large-scale object deformation. Proceedings of SPIE, 2015, , .	0.8	2
36	Autocollimation sensor for measuring the deformations of objects and modules containing environmentally hazardous substances. , $2016, \ldots$		2

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37	Optical-electronic system controlling the position of a railway track with the help of reference marks. , $2016, , .$		2
38	Design the algorithm compensation of vignetting error at optical-electronic autoreflection system by modelling vignetted image. , 2016, , .		2
39	System of the optic-electronic sensors for control position of the radio telescope elements. Proceedings of SPIE, 2016, , .	0.8	2
40	Optical elements for autocollimation strain-monitoring systems. Journal of Optical Technology (A) Tj ETQq0 0 () rgBT /Ove 0.4	erlock 10 Tf 50
41	Optoelectronic system on the base of the anamorphic element for the measuring of the elevation angles. , $2010, \ldots$		1
42	Investigation of a mathematical model of the system of electro-optical sensors for monitoring nonlinear surfaces. , 2015 , , .		1
43	Research of the use of autoreflection scheme to measure the error of the optical elements in space telescope $\hat{\epsilon}^{\text{TM}}$ s relative position. Proceedings of SPIE, 2015, , .	0.8	1
44	Remote optoelectronic sensors for monitoring of nonlinear surfaces. Proceedings of SPIE, 2015, , .	0.8	1
45	Optoelectronic SEMS for Preventing Object Destruction. Studies in Systems, Decision and Control, 2020, , 199-204.	1.0	1
46	Autocollimating system for precise measuring of three angular coordinates. , 2018, , .		1
47	Choosing parameters of active reference mark optical-electronic systems spatial position control. , 2019, , .		1
48	Optoelectronic System for Roll Angles Measuring of Maneuvering Objects Based on Anamorphosis Effect. Journal of Physics: Conference Series, 2006, 48, 988-991.	0.4	0
49	Research into New Type of a Control Element with Disturbed Prototype Configuration for Autocolimation Measurements. Journal of Physics: Conference Series, 2006, 48, 1008-1010.	0.4	O
50	Methods of data processing and estimation of measuring accuracy in stereoscopic system for the control of objects displacements. Proceedings of SPIE, 2010 , , .	0.8	0
51	Optic-electronic system for deformation of radio-telescope counter-reflector computer modeling. , 2014, , .		O
52	Investigation vignetting beams in optoelectronic autocollimation angle measurement system. Proceedings of SPIE, 2015, , .	0.8	0
53	Problem analysis of image processing in two-axis autocollimator. Journal of Physics: Conference Series, 2016, 735, 012039.	0.4	0
54	Trihedral Reflectors for Three-Axis Angular Autocollimation Measurements. , 2014, , .		O

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55	INVESTIGATION OF OPTICAL-ELECTRONIC AUTOCOLLIMATOR WITH QUADRANGULAR PYRAMIDAL REFLECTOR FOR MEASURING THE ANGULAR POSITION OF THE OBJECT. , 2014, , .		O
56	The optical-electronic autoreflection sensor for measurement an angle of rotation. , 2018, , .		0
57	The optical-electronic autoreflection sensor for angular deformations measurement. , 2019, , .		0